

80/565107

IAP20 Rec'd of 1/19 19 JAN 2006

Docket No.: 0630-2627PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Young-Man JEONG et al.

International Application No.: PCT/KR2003/001451

Application No.: NEW

Art Unit: N/A

Filed: January 19, 2006

Examiner: Not Yet Assigned

For: PLASMA SURFACE PROCESSING SYSTEM
AND SUPPLY DEVICE FOR PLASMA
PROCESSING SOLUTION THEREFOR

PRELIMINARY AMENDMENT

MS PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

This amendment includes:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.